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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 7319

SERIAL NUMBER 09/902,483	FILING DATE 07/11/2001 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. YO999-408 CIP
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## APPLICANTS

Cyril Cabral JR., Ossining, NY;

Kevin Kok Chan, Staten Island, NY;

Guy Moshe Cohen, Mohegan Lake, NY; Christian Lavoie, Ossining, NY;

Ronnen Andrew Roy, Ossining, NY;

Paul Michael Solomon, Yorktown Heights, NY;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CIP of 09/569,306 05/11/2000

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 07/30/2001

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	NY	6	22	4
Verified and Acknowledged	Examiner's Signature _____ Initials _____				

## ADDRESS

48150  
MCGINN INTELLECTUAL PROPERTY LAW GROUP, PLLC  
8321 OLD COURTHOUSE ROAD  
SUITE 200  
VIENNA , VA  
22182-3817

## TITLE

SELF-ALIGNED SILICIDE (SALICIDE) PROCESS FOR LOW RESISTIVITY CONTACTS TO THIN FILM  
SILICON-ON-INSULATOR AND BULK MOSFETS AND FOR SHALLOW JUNCTIONS

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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